

High-throughput techniques for measuring the spin Hall effect

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The spin Hall effect in heavy-metal thin films is routinely employed to convert charge currents into transverse spin currents and can be used to exert torque on adjacent ferromagnets. Conversely, the inverse spin Hall effect is frequently used to detect spin currents by charge currents in spintronic devices up to the terahertz frequency range. Numerous techniques to measure the spin Hall effect or its inverse were introduced, most of which require extensive sample preparation by multi-step lithography. To enable rapid screening of materials in terms of charge-to-spin conversion, suitable high-throughput methods for measuring the spin Hall angle are required. Here, we compare two lithography-free techniques, terahertz emission spectroscopy and broadband ferromagnetic resonance, to standard harmonic Hall measurements and theoretical predictions using the binary-alloy series $\text{Au}_x\text{Pt}_{1-x}$ as benchmark system. Despite being highly complementary, we find that all three techniques yield a spin Hall angle with approximately the same x dependence, which is also consistent with first-principles calculations. Quantitative discrepancies are discussed in terms of magnetization orientation and interfacial spin-memory loss.

INTRODUCTION

The spin Hall effect^{1–4} (SHE) converts a charge current with density j_c into a transverse spin current with density j_s . The charge-to-spin conversion efficiency can be characterized by the spin Hall angle (SHA) $\theta_{\text{SH}} = j_s/j_c$. It is commonly written as $\theta_{\text{SH}} = \sigma_{\text{SH}}/\sigma_{xx}$, where σ_{SH} is the spin Hall conductivity (SHC) and σ_{xx} is the longitudinal conductivity along the direction of the charge-current flow. Both intrinsic effects that are already present in perfectly periodic crystals and extrinsic effects, i.e. skew scattering and side-jump scattering, contribute to the spin Hall angle. In most practical cases, the electron scattering rate in a material is large due to point defects, grain boundaries, and phonons; therefore, the intrinsic mechanism dominates σ_{SH} . Following theoretical predictions,⁵ various crystalline heavy metals (HM) with large spin Hall conductivity were experimentally confirmed, such as Pt⁶, β -W⁷ and β -Ta⁸.

The SHC of crystalline materials is experimentally^{6,9–12} and theoretically^{5,13–16} well understood. The relation $\theta_{\text{SH}} = \sigma_{\text{SH}}/\sigma_{xx}$ was experimentally studied for Pt thin films⁶. This study partially explains the large range of reported SHAs in the literature for a single material and rationalizes the somewhat counterintuitive observation that thin films of lower quality and, thus, lower conductivity σ_{xx} have a larger SHA⁴. By alloying Pt with Au, it was shown¹⁷ that σ_{xx} can be decreased to increase the SHA.

The spin current originating from the SHE can be injected into an adjacent ferromagnetic (FM) layer where it gives rise to so-called field-like and damping-like spin-orbit torques^{18,19}. These may induce precession of the magnetization²⁰, domain-wall motion²¹ or switching of the magnetization orientation^{7,8,22}. Various promising concepts for SHE-based magnetic memory devices, so called spin-orbit torque magnetic random-access memories (SOT-MRAMs) were proposed^{23–26}.

To quantify the SHA or the SHC experimentally, numerous techniques were developed, as detailed in the reviews of Refs. 3 and 4 and references therein. The various techniques can differ significantly, for example with respect to the driving perturbation, probed observable, magnetization and external-field geometry, use of either the direct or the inverse SHE and covered frequency range. On one hand, several ferromagnetic-resonance (FMR)-based techniques were used, such as (i) FMR spin pumping with subsequent detection of the inverse SHE (ISHE)²⁷ and (ii) SHE-induced modulation of the linewidth in an FMR experiment due to the action of the damping-like torque from the spin current²⁸. The quantification of the SHE relies on either measuring the rectified voltages generated by the inverse SHE, or on determining the modulation of the FMR linewidth, which originates from the damping-like spin-orbit torque. On the other hand, electrical transport techniques were developed that employ nonlocal spin injection,²⁹ the spin Hall magnetoresistance,³⁰ magnetic loop shifts³¹ or measure the deflection of the magnetization and the resulting change in the anomalous Hall

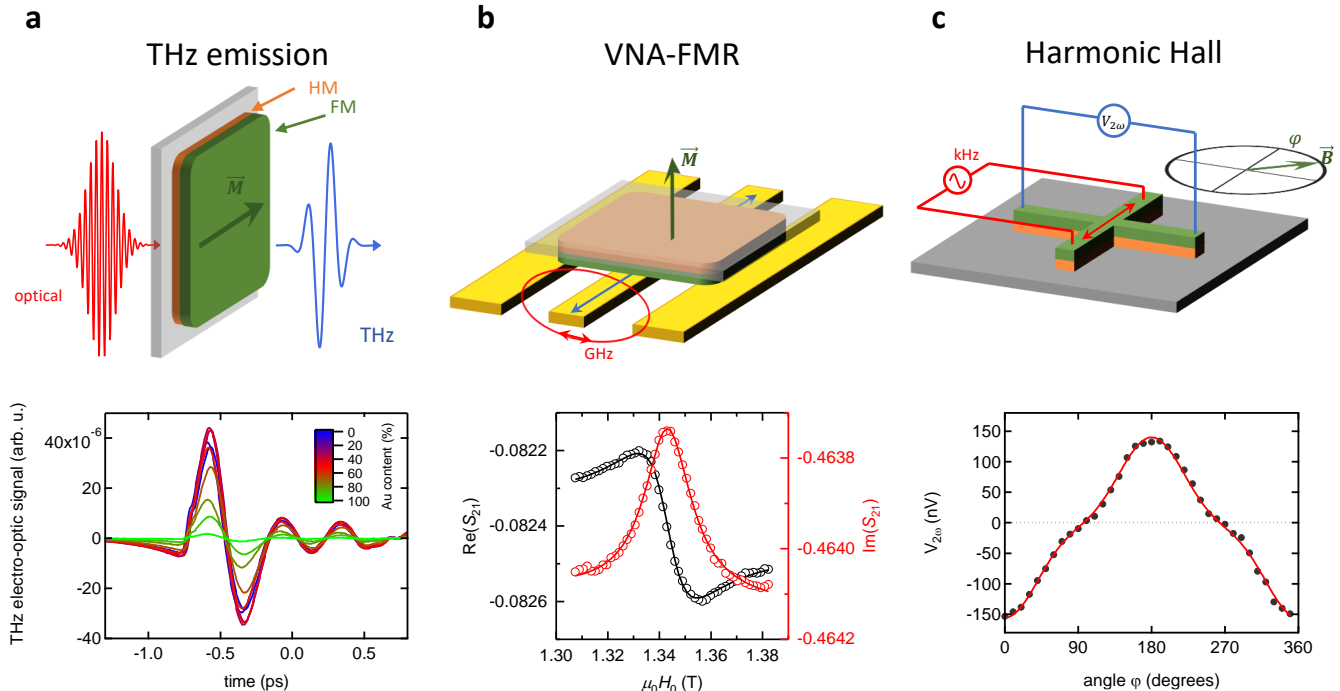


FIG. 1. Overview of three different techniques to determine the spin Hall angle of a material as described in the text. The top row shows schematic of the techniques, while the bottom row shows typical raw data. (a) THz emission spectroscopy: an optical laser pulse generates an ultrafast heat pulse in the films. Due to the spin-dependent Seebeck effect, a spin current flows from the ferromagnetic layer (FM) into the heavy metal layer (HM). The inverse spin Hall effect converts the spin current into a charge pulse, which emits THz radiation. (b) Vector-network-analyzer ferromagnetic resonance (VNA-FMR): a GHz current in the coplanar waveguide excites the ferromagnetic resonance in the FM. Spin pumping drives a spin current into the HM layer, where it is converted into an oscillating charge current. Its magnetic field couples into the waveguide and can be detected in the complex-valued waveguide transmission signal S_{21} . (c) Harmonic Hall measurements: A kHz charge current drives an oscillating spin current from the HM into the FM layer. The associated spin-orbit torque drives an oscillating deflection of the magnetization out of the film plane. The associated oscillating anomalous Hall voltage is detected as a second-harmonic transverse voltage in the Hall cross.

effect.⁸ All of these techniques are in principle quantitative and have in common that relatively tedious lithographic preparation of microdevices is required.

Materials with large SHA can be tailored by alloying,^{17,32,33} which decreases the conductivity and tunes the Fermi level close to maxima of the SHC. Also, phase transitions in binary or ternary phase diagrams can be exploited, or amorphous metals with low conductivity may be created by enforced mixing of immiscible elements.³⁴ The associated maxima in the SHA as a function of composition can be quite narrow, such that optimization requires a large number of samples to be investigated. Lithography is time-consuming and, thus, a limiting factor for high-throughput SHA characterization. Therefore, compatible methods that do not require any additional processing steps are highly desirable. Recently, two promising techniques potentially fulfilling this need have become available: THz emission spectroscopy (TES, Fig. 1a, top) and vector network analyzer (VNA) FMR (VNA-FMR, Fig. 1b, top). Despite their relevance for

rapid sample characterization, their performance has not yet been compared to each other and a well-established technique such as harmonic Hall response (HHR, Fig. 1c, top). Recent work that experimentally compared the spin Seebeck effect at dc and THz frequencies indicates that TES has large potential for material characterization with results that are consistent with static methods³⁵.

In this article, we demonstrate that both TES and VNA-FMR are suitable techniques to quickly obtain quantitative measurements of the SHA of a metallic binary alloy series. Both methods do not require any post-deposition sample processing and feature data acquisition times on the timescale of minutes (TES) to hours (VNA-FMR). We compare the results from these two high-throughput methods to harmonic Hall response measurements, which utilize a single lithography step and serve as a reference.^{36–39} In addition, we compare our results with first-principles calculations.¹⁷ Although the three methods are very different in terms of frequency windows, spin current generation, and detection schemes, we find a qualitatively good

agreement between them.

EXPERIMENTAL DETAILS

Sample system

To benchmark our techniques, we use a series of Au-Pt binary alloys. Thin-film stacks of $\text{Au}_x\text{Pt}_{1-x}$ (3 nm)|CoFeB(3 nm)|Si(1.5 nm) were grown by dc unbalanced magnetron co-sputtering in a 2" sputtering system at room temperature. For TES and VNA-FMR experiments, the samples were not processed any further. For the harmonic Hall measurements, the samples were patterned with Hall cross devices with fourfold rotational symmetry and a line width of 16 μm by standard optical lithography and Ar-ion-beam milling. All samples were checked by X-ray diffraction, X-ray reflectivity, X-ray fluorescence and four-point dc conductivity measurements.

The in-plane conductivities σ_{xx} of the Au-Pt alloy layers are shown in Fig. 2a, where a parallel-conductor model was applied to remove the contributions from the CoFeB layers ($\sigma_{\text{CoFeB}} = 5.7 \times 10^5 \text{ S/m}$). The corresponding conductivity of the Pt layer ($2.78 \times 10^6 \text{ S/m}$) is quite typical for a thickness of 3 nm.^{6,10,40} As expected, doping with Au reduces σ_{xx} substantially. The conductivity of Au-rich samples remains low, because of the pronounced island growth of Au on SiO_2 surfaces. In the following, we discuss key aspects of the employed spin Hall measurement techniques and present respective results. Additional technical details are provided in the Appendix.

Method (a): Terahertz emission spectroscopy

In TES, a HM|FM bilayer under study is excited by a femtosecond laser pulse (Fig. 1a, top), thereby inducing ultrafast spin transport from the FM into the HM layer through an ultrafast version of the spin-dependent Seebeck effect.^{41–44} In the HM, the laser-driven longitudinal spin current is converted into a transverse charge current by the ISHE. The resulting sub-picosecond charge current⁴⁵ gives rise to the emission of electromagnetic radiation at THz frequencies.⁴¹

The THz waveforms of Fig. 1a (bottom) are raw data obtained with this technique. The emission amplitudes are modeled as a function of THz frequency $\omega/2\pi$ as⁴¹

$$S_{\text{THz}}(\omega) = AB(\omega)\lambda_s \cdot \tanh\left(\frac{t_{\text{HM}}}{2\lambda_s}\right) \cdot \theta_{\text{SH}} \cdot Z(\omega). \quad (1)$$

Here, A is the pump-light absorptance, while the factor B captures the photon-to-spin-current conversion efficiency and the detector response function⁴⁶. B is assumed to be independent of the alloy composition in our experiment, thereby neglecting possible variations of the spin-current strength due to, e.g., variations of the interface quality for different Au concentrations.

The spatial shape of the spin current in the HM layer is captured by the spin-current relaxation length λ_s and the HM layer thickness t_{HM} . According to transport theory based on the Boltzmann equation⁴⁷, λ_s equals the spin diffusion length at zero frequency, but becomes comparable to the mean free path length at THz frequencies.

While the spin-to-charge-current conversion in Eq. (1) is quantified by θ_{SH} , the charge-current-to-electric-field conversion is described by the bilayer impedance

$$Z(\omega) = \frac{Z_0}{n_1(\omega) + n_2(\omega) + Z_0 \int_0^d dz \sigma_{xx}(z, \omega)} \quad (2)$$

where $n_1(\omega)$ and $n_2(\omega)$ are the refractive indices of air and the substrate, respectively, $Z_0 = 377 \Omega$, and $\sigma_{xx}(z, \omega)$ is the in-plane conductivity of the material at depth z . For simplicity, we take σ_{xx} as constant across the film thickness and ignore the frequency dependence, because the frequencies used here are well below the Drude frequency of the material.

The SHA relative to a reference sample can be obtained for all alloy stoichiometries when λ_s is known. Here, we take λ_s as the electron mean free path λ_{MF} and use $\lambda_{\text{MF}}/\sigma_{zz} = 0.3 \times 10^{-15} \Omega \text{ m}^2$ where σ_{zz} is the electrical conductivity of the HM perpendicular to the film plane.^{6,40} Measuring σ_{zz} is impractical, so we employ the approximation $\sigma_{zz} \approx \sigma_{xx}$.

Note that θ_{SH} of Eq. (1) is an effective SHA which, in addition to spin-to-charge-current conversion in the HM layer, contains such conversion also in the FM layer and at the FM/HM interface. Notably, all THz measurements, i.e. THz emission, pump absorptance and THz conductivity, were conducted within less than 8 h.

Method (b): VNA ferromagnetic resonance

In VNA-FMR, we inductively detect microwave currents generated in HM|FM bilayers under the condition of FMR, which allows one to determine the SHC. The sample is placed face-down on a coplanar waveguide (CPW) (Fig. 1b, top). A GHz current excites resonant spin precession (FMR) in the FM part of the bilayer. Due to spin pumping, a spin current flows into the HM layer where it is converted into a charge current by the ISHE. The magnetic field created by this current couples back into the CPW and is extracted from the CPW transmission signal to obtain the complex-valued SOT conductivity σ^{SOT} . This quantity is directly linked to the SHC.^{48,49}

Raw data obtained by VNA-FMR are the real and imaginary part of the CPW transmission S_{21} as a function of external magnetic field at fixed continuous-wave frequency (Fig. 1b, bottom). The S_{21} data is fitted to Eq. (8) and from Eq. (10) (see Methods section), we obtain the complex-valued normalized inductance \tilde{L} of the HM|FM bilayer at frequency ω . For each sample, the S_{21} measurements and extraction of \tilde{L} are performed for frequencies $5 \text{ GHz} < \omega/2\pi < 40 \text{ GHz}$. The generation

of charge currents in the HM|FM bilayer under FMR conditions results in a linear frequency dependence of \tilde{L} . The dc value $\tilde{L}(\omega = 0)$ is the real-valued inductance of the HM|FM bilayer in the absence of any currents in the bilayer. To extract the complex-valued SOT conductivity $\sigma_e^{\text{SOT}} = \sigma_e^{\text{SOT}} + i\sigma_o^{\text{SOT}}$, \tilde{L} is fitted by⁴⁸

$$\tilde{L}e^{i\phi_a} = \eta^2 \frac{\mu_0 t_{\text{FM}} l}{4w_C} + \eta\omega \frac{\hbar L_{12} \sigma_e^{\text{SOT}}}{2eM_s}. \quad (3)$$

The first term on the right side of (3) is the frequency-independent dipolar inductance stemming from the precessing magnetization. The second term is the linearly frequency-dependent inductance due to the ac currents flowing in the normal metal⁴⁸. In (3), $w_C = 56 \mu\text{m}$ is the width of the CPW center conductor, $l = 8.7 \text{ mm}$ is the sample length, $L_{12}(d)$ is the mutual inductance between sample and CPW and $0 < \eta(d) < 1$ is a unitless spacing loss as defined in⁴⁸. Fit parameters are the separation d between sample and CPW, the anomalous phase ϕ_a and the spin-orbit torque conductivities σ_e^{SOT} and σ_o^{SOT} , where the even component σ_e^{SOT} also contains the effect of currents induced by Faraday's law of induction. The odd component σ_o^{SOT} is directly related to the damping-like spin-orbit torque.

While the SOT conductivities can thus directly be measured using VNA-FMR, extraction of the microscopic parameters, in particular the spin Hall angle, requires use of a suitable model and parameters^{48,49}. A lower limit of the spin Hall angle can be obtained by

$$\theta_{\text{SH}} = \sigma_o^{\text{SOT}} / \sigma_{xx}, \quad (4)$$

where we again assume $\sigma_{xx} \approx \sigma_{zz}$. We note that Eq. (4) assumes a completely transparent interface and thus vanishing spin backflow and spin memory loss (SML). As previously demonstrated^{48,49}, we thus may underestimate the spin Hall angle by a factor ≈ 10 . This underestimation is predominantly caused by the expected strong SML in HM/FM bilayers^{48,49}. Quantification of the SML is in principle possible, but would require a thickness-series of both HM and FM layers for each composition⁴⁹. We use Eq. (4) here for a fair comparison of the VNA-FMR evaluation to the reference measurements based on the Harmonic Hall response (see next section), where the same assumptions are made.

Method (c): Harmonic Hall response

Harmonic Hall voltage measurements are performed by injecting an ac current with amplitude I_0 at frequency $\omega/2\pi$ into the Hall crosses measuring the in-phase first harmonic and out-of-phase second harmonic Hall voltages simultaneously upon in-plane field rotation with a lock-in amplifier (Fig. 1c, top). The SOT gives rise to a periodic deflection of the magnetization with in-plane and out-of-plane components, which can be detected via the planar Hall effect and the anomalous Hall effect, respectively.

The second-harmonic out-of-phase Hall voltage rms value $V_{2\omega}$ depends on the in-plane angle φ between current and magnetization (Fig. 1c, bottom) and can be written as^{34,39}

$$V_{2\omega} = \left(-\frac{B_{\text{FL}}}{B_{\text{ext}}} R_{\text{P}} \cos(2\varphi) - \frac{1}{2} \frac{B_{\text{DL}}}{B_{\text{eff}}} R_{\text{A}} + \alpha' I_0 \right) I_{\text{rms}} \cos \varphi. \quad (5)$$

Here, $B_{\text{eff}} = B_{\text{ext}} + B_{\text{sat}}$ is the effective field, B_{FL} and B_{DL} are the current-induced effective field amplitudes associated with the field-like (FL) and damping-like (DL) spin-orbit torques.¹⁹ It is assumed that in-plane anisotropy fields (e.g. uniaxial and biaxial) are small compared to the external magnetic field B_{ext} (0.2 T to 1 T) and can be neglected. The term $\alpha' I_0$ describes a parasitic contribution arising from the anomalous Nernst effect (ANE),³⁸ where $I_{\text{rms}} = I_0/\sqrt{2}$. R_{P} and R_{A} are the amplitudes of the planar and anomalous Hall resistances at saturation, respectively. B_{ext} is the external magnetic field and B_{sat} is the perpendicular saturation field.

Equation (5) is fitted to the experimental data, and damping-like effective fields and anomalous-Nernst contributions are separated by their dependence on the external field. The spin Hall angle is obtained from the damping-like effective field as

$$\theta_{\text{SH}} = \frac{2e}{\hbar} \frac{B_{\text{DL}} M_s t_{\text{FM}}}{j_{\text{HM0}}}, \quad (6)$$

where j_{HM0} is the current density amplitude in the heavy-metal layer far away from the Hall voltage pickup lines. In this expression, effects of spin memory loss, spin backflow or spin transparency of the interface are neglected. Therefore, the SHA obtained by this formula is a strict lower bound to the true SHA of the HM layer. A correction factor of 1.45 for the inhomogeneous current flow in the Hall crosses was applied to the spin Hall angle, as suggested by a recent study on the influence of the aspect ratio of the Hall cross on the effective field determination.⁵⁰

First-principles calculations

For the first-principles calculations, we employ the Kubo-Bastin linear response theory as implemented in the Munich SPR-KKR package.^{51–53} Starting from a density functional theory description of the electronic structure of the chemically disordered alloy, linear response calculations including phonon effects via the alloy analogy model are performed to obtain the full spin-resolved conductivity tensor. The method treats the intrinsic SHC and the extrinsic effects on the same footing via so-called vertex corrections. In the nonzero-temperature calculations, the contributions due to the vertex corrections are, however, very small compared to the intrinsic spin Hall conductivity.

The longitudinal charge conductivity determined by the SPR-KKR package refers to bulk. Interface scattering is known to reduce the conductivity σ_{xx} of thin films,

which can be estimated via the Mayadas-Shatzkes (MS) model,⁵⁴

$$\frac{\sigma_{xx}}{\sigma_{xx0}} = \left[1 + \frac{3\lambda_{\text{MF}}}{8t_{\text{HM}}} \left(1 + \frac{p}{2} \right) + \frac{3\lambda_{\text{MF}}}{2D_{\text{HM}}} \left(\frac{r}{1-r} \right) \right]^{-1}. \quad (7)$$

Here, σ_{xx0} is the bulk conductivity from the SPR-KKR calculation, t_{HM} is the film thickness, D_{HM} is the lateral grain size. For our material system, the electron mean-free path λ_{MF} is calculated as $\lambda_{\text{MF}}/\sigma_{xx} = 0.3 \times 10^{-15} \Omega \text{ m}^2$. A reasonable fit of the data is obtained with $D_{\text{HM}} \approx 5 \text{ nm}$ and both the specularity parameter p and the grain boundary reflectivity parameter r set to 0.5.

RESULTS AND DISCUSSION

Figures 2b-c show the major results obtained with the three methods employed here. Regarding TES, Fig. 2b displays the THz emission amplitude (right axis) and the SHA as extracted using Eq. (1) (left axis). Both quantities are normalized to those of the pure Pt layer ($x = 0$). The THz emission amplitude exhibits a maximum at a Au fraction of $x \approx 0.4$, which is even more pronounced in the relative SHA. The reason for this difference is the monotonic decay of the HM conductivity (Fig. 2a) and the electron mean-free path leading to a decreasing spin-current relaxation length λ_s with increasing x .

Concerning the VNA-FMR measurements, Fig. 2c shows the odd component of the SOT conductivity (right axis) and the SHA (left axis) as obtained through Eq. (4). The SOT conductivity features a broad plateau around $x \approx 0.33$ and decays with increasing Au content. The $\sigma_o^{\text{SOT}} \approx 2 \times 10^4 \text{ S/m}$ measured for $x = 0$ (pure Pt) is in good agreement with $\sigma_o^{\text{SOT}} \approx 3 \times 10^4 \text{ S/m}$ measured for Pt/NiFe with the same technique⁴⁸. As the charge conductivity decreases with increasing x (Fig. 2a), a local maximum of θ_{SH} arises around $x \approx 0.4$.

Finally, the SHA as determined by the HHR method is displayed in Fig. 2d. These measurements feature a local maximum around $x \approx 0.33$. As we have determined both the SHA θ_{SH} and the conductivity σ_{xx} of the HM layer, we can also compute its SHC through $\sigma_{\text{SH}} = \theta_{\text{SH}}\sigma_{xx}$.

To better compare the outcome of the three methods, Figs. 3a and 3b display, respectively, the measured SHAs and SHCs scaled to the HHR results of the pure Pt film ($x = 0$). We find that the scaled SHAs vs Au fraction x show similar trends, in particular in terms of the position of the SHA maximum. All three results are also in reasonable agreement with a previous experiment on the Au-Pt system.¹⁷

In particular, the TES data are in excellent overall agreement with the HHR data with some discrepancies in both the SHA and SHC around $x \approx 0.2$: The HHR method finds an initial increase of the SHC with increasing x , whereas the TES data suggest a monotonic decrease of the SHC with increasing x .

While TES delivers SHA and SHC values relative to a

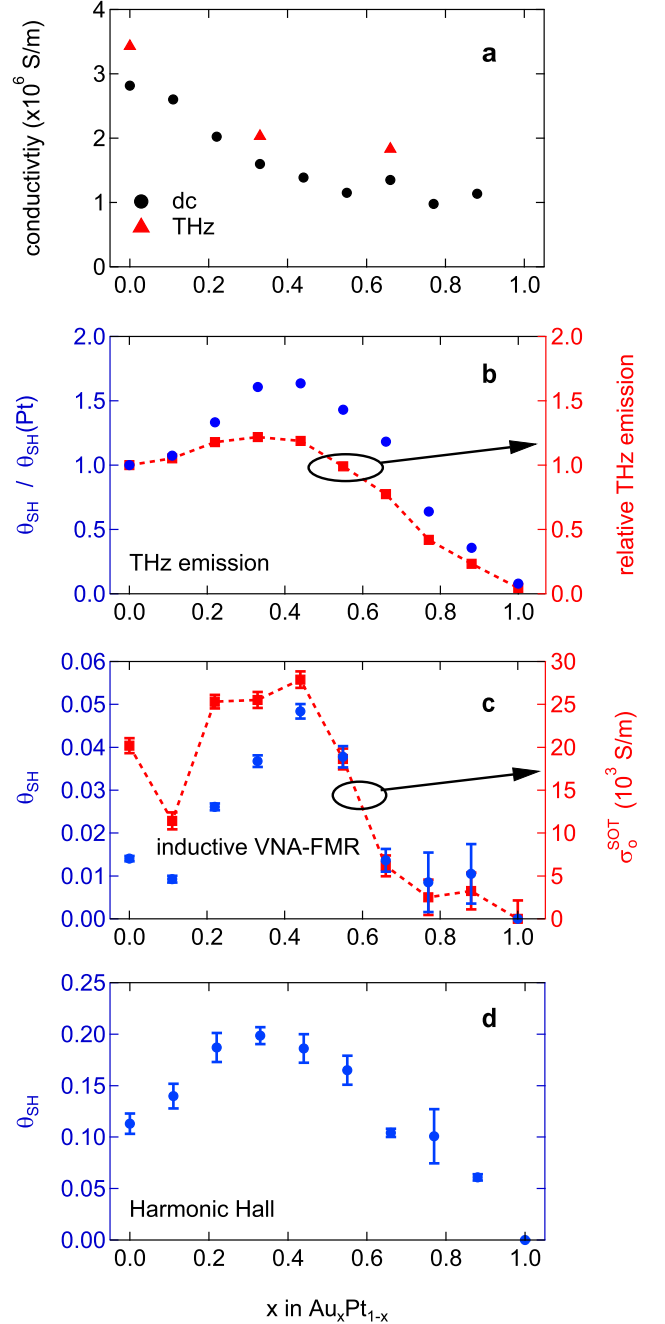


FIG. 2. (a) Electrical conductivities of the $\text{Au}_x\text{Pt}_{1-x}$ alloy films determined by four-point dc conductivity measurements and by THz transmission measurements. In both cases, a parallel conductor model was applied to subtract the CoFeB layer conductance. (b) Relative THz emission (right axis) and relative spin Hall angle (left axis) as obtained from Eq. 1. (c) Odd component of the spin-orbit torque conductivity (right axis) obtained in the VNA-FMR measurements and extracted lower-bound spin Hall angle $\theta_{\text{SH}} = \sigma_o^{\text{SOT}}/\sigma_{xx}$ (left axis). (d) Spin Hall angles as determined with the harmonic Hall response method via Eq. (6).

reference HM (such as Pt), both VNA-FMR and HHR

provide absolute values. The HHR SHA of the 3 nm pure Pt film ($x = 0$) is found to be $\theta_{\text{SH}}^{\text{Pt}} \approx 0.11 \pm 0.01$, whereas the maximum SHA at $x = 0.33$ amounts to 0.20 ± 0.01 . The $x = 0$ value of the SHA agrees very well with other recent measurements on Pt films with similar conductivities.^{6,10,31} Interestingly, our VNA-FMR SHA values of pure Pt are a factor of approximately 4 to 10 smaller than those from the HHR measurements. Because we have assumed vanishing spin backflow and vanishing SML for evaluation of both VNA-FMR and HHR data [see Eqs. (4) and (6)], this discrepancy indicates that at least one of these neglected parameters is substantially different between these techniques.

Because spin backflow is typically only a small correction for the investigated all-metallic FM/Pt system with effective spin mixing conductances exceeding 10^{19} m^{-2} for metallic magnets⁵⁵, we speculate that the discrepancy is predominantly caused by a difference in SML.

The SML⁵⁶ has been found to be strong in previous FMR-based experiments^{48,49,57,58}, where up to 90% of the spin information can be lost at the metallic FM/Pt interface⁴⁸. To reconcile our FMR and HHR measurements quantitatively in the context of SML alone, we have to assume a factor 5 to 10 difference in SML between these two techniques. Unfortunately, the SML cannot be unambiguously determined from the existing sample series. We can thus only speculate that the difference might be due to one of the following reasons: a) The VNA-FMR measurements are performed in out-of-plane geometry, the HHR measurements in the in-plane geometry. b) The VNA-FMR measurements are sensitive to the transverse dynamic magnetization components, while the HHR measurements are quasi-static. This could lead to enhanced spin dephasing in the FMR measurements, for instance in a thin layer of proximity-polarized Pt.

Because no absolute values for the SHA can be extracted from the TES measurements, no conclusion about a possible SML at THz frequencies can be drawn. A quantitative evaluation of SML between the different experimental geometries would be highly interesting but is left for future studies that concentrate on a single material system.

In addition to this possible dependence of the SML on experimental geometry, further magnetization-direction dependent corrections to the SHA may exist. For instance, a potential spin-rotation at the interface⁵⁹ might depend on the geometry. All these corrections can, in addition, depend on the stoichiometry due to modifications of the film resistivities and the interfacial electronic structure matching.

To gain more insight into the observed composition dependence of the measured SHA, Fig. 3 also displays the unscaled first-principles results for the SHA, SHC and the charge conductivity of $\text{Au}_x\text{Pt}_{1-x}$ vs x . The experimental results for the SHA from the HHR method agree very well with the SPR-KKR calculation without the conductivity reduction from the MS model (see above). Inclusion of the MS model predicts a larger SHA for all stoichiometries.

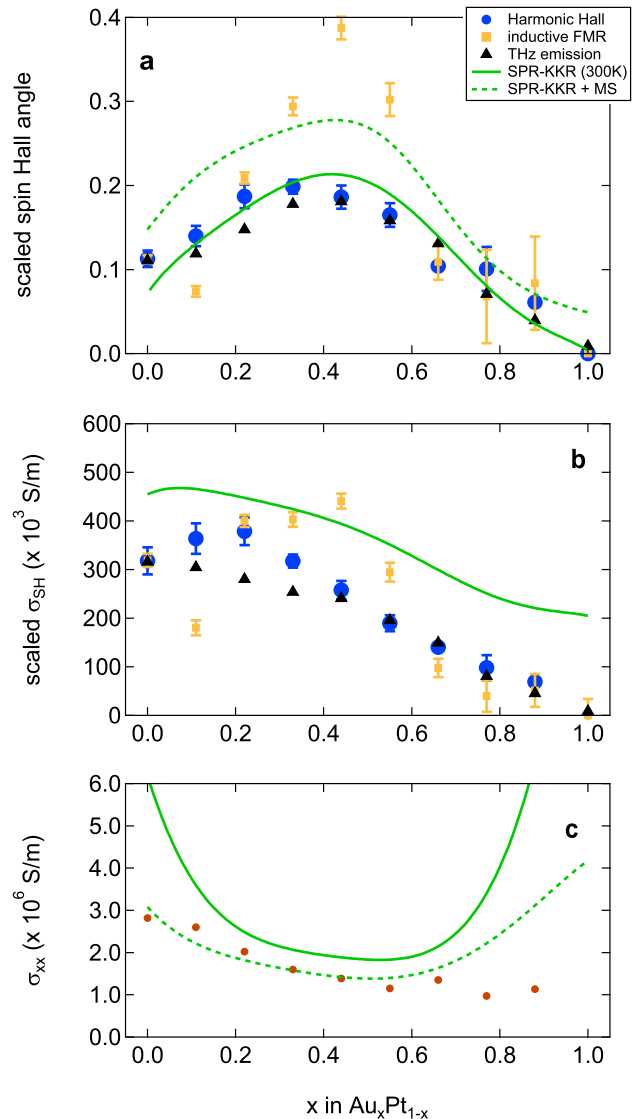


FIG. 3. (a) Experimental spin Hall angles scaled to the spin Hall angle of the pure Pt sample obtained with the harmonic Hall response method. Green lines represent results from SPR-KKR calculations including or neglecting thin-film corrections of the conductivity via the Mayadas-Shatzkes (MS) model. (b) Scaled spin Hall conductivities as in (a). The green line represents the SPR-KKR calculation. (c) Electrical conductivity as measured electrically (dots), as calculated including corrections from the MS model (dashed line).

This effect can be traced back to the SHC, which is larger in the calculation than in the experiment (Fig. 3b). At the same time, the film conductivity is smaller than what is predicted by SPR-KKR including the MS model for large Au content. The large deviation at high Au content can be attributed to island growth (see above), leading to strong grain-boundary scattering and, thus, to much lower conductivity than expected from the MS model

with a single set of parameters.

Both techniques that provide quantitative results for the SHA and the SHC, the VNA-FMR method and the harmonic Hall response method, show smaller SHC than predicted by the SPR-KKR calculations. This trend may be explained by the already mentioned neglect of interfacial spin memory loss. Other effects that may reduce the spin current include interfacial spin transparency and interfacial spin-orbit coupling.⁶⁰ The reduced spin current density manifests itself either as less damping-like spin-orbit torque observed in the harmonic Hall measurements, or as less detected charge current density in the inductive VNA-FMR experiment.

CONCLUSION

Although an accurate determination of the internal SHA of a given material is of great fundamental interest, in high-throughput experiments, it is often sufficient to observe a trend in relative terms, rather than measuring absolute values. To date, studies on the SHE have mostly focused on elements and binary alloys and compounds. Therefore, we are only at the beginning of mapping out the SHE in ternary, quaternary and more complex alloys and compounds. For an efficient search for materials with large SHA or large SHC, high-throughput techniques for measuring these properties are necessary, and the two techniques presented here, VNA-FMR and THz emission spectroscopy, are now proven tools for future experimental work.

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APPENDIX

A. Sample fabrication

Thin film heterostructures of Substrate|Au_xPt_{1-x}(3 nm)|Co₄₀Fe₄₀B₂₀(3 nm)|Si(1.5 nm) were grown by magnetron sputtering at room temperature. For the THz emission experiments and for the inductive GHz measurements, we used polished fused silica substrates. Si wafers with a 50nm thermal oxide layer were used for the low-frequency harmonic Hall measurements. The Pt-Au alloys were made by magnetron co-sputtering from two elemental targets. All samples were exposed to a pure oxygen plasma via the Si source prior to deposition to clean the substrate surface. The Pt-Au stoichiometries were verified by

x-ray fluorescence spectroscopy. For all samples, the film thicknesses and crystallographic phases were checked by x-ray reflectivity and diffraction measurements.

For the THz emission spectroscopy and the inductive GHz measurements, the samples were not subjected to further processing. For the harmonic Hall measurements, the samples on Si|SiOx wafers were lithographically patterned into Hall crosses with an arm width of 16 μm and bonded into DIL-24 packages. During the lithographic processing, the films were heated to 90°C for 20 min. No effect of the heating was seen in subsequent conductivity and x-ray diffraction measurements.

B. THz emission spectroscopy

The THz emission was driven with ultrashort laser pulses from a Ti:Sa oscillator with pulse duration of 10 fs, central wavelength of 800 nm, repetition rate of 80 MHz, and pulse energy of about 1 nJ. The THz transient was measured via electro-optic sampling⁶¹ in a 1-mm-thick ZnTe (110) crystal with a weak copropagating 10-fs near-infrared probe pulse from the same laser. The electrical conductivities of the AuPt alloy were obtained by THz transmission measurements as detailed in Refs. 44 and 62.

C. VNA-FMR measurements

A static magnetic field H is applied along the bilayer normal. FMR is excited by passing a microwave current of fixed frequency ω through the CPW while sweeping the magnitude of H . At each value of H , the complex-valued microwave transmission $S_{21}(H)$ through the CPW is recorded with the VNA. Experiments are repeated for $10 \text{ GHz} \leq \omega/2\pi \leq 40 \text{ GHz}$. For each ω , the obtained $S_{21}(H)$ spectra are fitted to

$$S_{21}(H) = S_{21}^0 - iA \frac{\chi(H)}{M_s}, \quad (8)$$

where S_{21}^0 is the H -independent transmission through the CPW outside FMR conditions, A is a complex-valued scaling parameter, $\mu_0 M_s = 1.05 \text{ T}$ is the saturation magnetization and

$$\chi(H) = \frac{M_s (H - M_{\text{eff}})}{(H - M_{\text{eff}} + i\Delta H)^2 - H_{\text{eff}}^2}, \quad (9)$$

is the diagonal component of the Polder susceptibility tensor.⁶³ Here, $M_{\text{eff}} = H_{\text{res}} - H_{\text{eff}}$ and $H_{\text{eff}} = \omega/(\mu_0\gamma)$, where γ is the gyromagnetic ratio.⁶⁴ After fitting the data to Eq. (8), as detailed in 64 we extract the normalized inductance⁴⁸

$$\tilde{L} = \frac{L}{\chi(H_{\text{res}})} = \frac{2AZ_0}{\omega M_s S_{21}^0}, \quad (10)$$

with the impedance of the CPW $Z_0 = 50 \Omega$. Due to the normalization by S_{21}^0 in Eq. (10), \bar{L} is quantitatively determined without any calibration of the microwave circuit. Furthermore, the Gilbert damping α_{tot} is obtained by fitting the ΔH vs. ω data to

$$\Delta H = \frac{\omega}{\mu_0 \gamma} \alpha_{\text{tot}} + \Delta H_0, \quad (11)$$

with the inhomogeneous linewidth broadening ΔH_0 .

D. Harmonic Hall measurements

For the determination of the spin Hall angle, the films were patterned into 4-fold rotationally symmetric Hall crosses with a conductor width of $w = 16 \mu\text{m}$ and a length of $l = 48 \mu\text{m}$ by optical lithography. Harmonic Hall voltage measurements were performed in a dual Halbach cylinder array with a rotating magnetic field up to 1.0 T (MultiMag, Magnetic Solutions Ltd.). An ac current density with an rms value of $j_{\text{rms}} = 2 \times 10^{10} \text{ A m}^{-2}$ ($I_{\text{rms}} = 1.92 \text{ mA}$) and frequency $\omega/2\pi = 3219 \text{ Hz}$ was injected into the Hall crosses and the in-phase first harmonic and out-of-phase second harmonic Hall voltages were recorded simultaneously upon in-plane field rotation with a Zurich Instruments MFLI multi-demodulator lock-in amplifier. The out-of-plane saturation component of the effective field $B_{\text{eff}} = B_{\text{ext}} + B_{\text{sat}}$ is $B_{\text{sat}} = B_{\text{dem}} - B_{\text{ani}} > 0$. It was obtained together with the anomalous Hall resistance amplitude R_A from Hall voltage measurements in a perpendicular magnetic field up to 2.2 T. The planar

Hall amplitudes R_P were obtained from the first harmonic $V_\omega = R_P I_{\text{rms}} \sin 2\varphi$. The parasitic ANE component $\alpha' I_0$ yields an electric field $\mathbf{E}_{\text{ANE}} = -\alpha \nabla T \times \mathbf{m} \propto I_0^2$, where I_0 is the current amplitude. The prefactor α' summarizes all geometrical parameters and the film electrical conductivity, heat conductivity, etc. that determine ∇T . The magnetization of the CoFeB film was determined by alternating gradient magnetometry to be $M_s = (1050 \pm 50) \text{ kA/m}$. The parallel circuit model was applied to determine the current density flowing in the HM layer.

E. Linear response calculations

The spin Hall conductivities were calculated within a fully relativistic multiple-scattering Green function framework using the Kubo-Bastin formalism¹⁴. Intrinsic and extrinsic contributions to the spin Hall conductivity are treated on equal footing. Furthermore, chemical alloying as well as temperature are treated on equal footing within the coherent potential approximation (CPA), or the alloy-analogy model (AAM), respectively⁵¹. The formalism is implemented in the Munich Spin-Polarized Relativistic Korringa-Kohn-Rostoker (SPR-KKR) code^{52,53}. The Green function was expanded up to $\ell_{\text{max}} = 3$ and the Fermi energy was accurately obtained with Lloyd's formula. The atomic sphere approximation (ASA) was used throughout. Dense k-point meshes were used to ensure an accurate evaluation of the Brillouin zone integrals for the Fermi surface term. For more details see Ref. 17.

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